

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

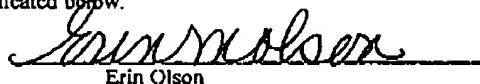
In re Application of: Eric Bornstein  
Application Serial No.: 10/649,910  
Filing Date: 26 August 2003  
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER SYSTEM  
Examiner: Jastrzab, Krisanne Marie  
Art Unit: 1744  
Atty. Docket No.: 072287-0019  
Confirmation No.: 5770

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**CERTIFICATE OF MAILING OR TRANSMISSION**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 13 October 2006



Erin Olson

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

***AMENDMENT - ELECTION WITH TRAVERSE***

This paper is in response to the Office Action dated 02 October 2006, with included restriction requirement, for the above-identified application.

The Applicant requests that subject application be amended in accordance with the following:

- ***Amendments to the Claims***, as listed in the listing of claims beginning on page 2 of this paper; and
- ***Remarks***, beginning on page 6 of this paper.